

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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Title of Invention

ETCHING OPENINGS OF DIFFERENT DEPTHS USING A
SINGLE MASK LAYER METHOD AND STRUCTURE

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Confirmation Number:

First Named Applicant: David Dobuzinsky

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or 6221780 or 6255211 or 6566276 or 6406963 or 6361837 or 6211035 or 6351039
or 6472312 or 6025276).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6709978	2004-03-23	Geusic et al			
	2	6710447	2004-03-23	Nogami			
	3	6667223	2003-12-23	Seitz			
	4	6617224	2003-09-09	Yu et al			
	5	6541349	2003-04-01	Arthanari et al			
	6	6180489	2001-01-30	Yang et al			
	7	6303733	2001-10-16	Lau et al.			
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	24	6566276	2003-05-20	Maloney et al			
	25	6406963	2002-06-18	Woerlee et al			
	26	6361837	2002-03-26	Pangrie et al			
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	29	6472312	2002-10-29	Bao et al			
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Signature

Examiner Name	Date